

L Number	Hits	Search Text	DB	Time stamp
3	9	((peabody).att.) and (catalytic and laser) and (remove with oxide)	USPAT	2001/10/11 09:04
4	0	((peabody).att.) and (catalytic and laser) and (remove with oxide) and levling	USPAT	2001/10/11 08:57
5	0	((peabody).att.) and (catalytic and laser) and (remove with oxide) and leveling	USPAT	2001/10/11 08:58
6	0	((peabody).att.) and (catalytic and laser) and (remove with oxide) and planarize	USPAT	2001/10/11 08:59
7	3	((fish with richardson).att.) and ((semiconductor adj energy adj laboratory).as.)) and (catalytic and laser) and (planarize or leveling or flatten or smoothen)	USPAT	2001/10/11 08:59
8	1	((peabody).att.) and (catalytic and laser) and (remove with oxide) and ((planarize or planarization or planarized or flat or flatten or flaten or flattened or leveling or level or smooth or smoothen) with (heat or thermal or heated or heating))	USPAT	2001/10/11 09:05
-	459	((("438/149") or ("438/479"))).CCLS.	USPAT	2001/10/10 15:45
-	1277	((("438/149") or ("438/479") or ("438/517") or ("438/151") or ("438/473") or ("438/476") or ("438/486") or ("438/487") or ("438/491"))).CCLS.	USPAT	2000/09/21 14:38
-	139	((("438/149") or ("438/479") or ("438/517") or ("438/151") or ("438/473") or ("438/476") or ("438/486") or ("438/487") or ("438/491"))).CCLS.) and (nickle or Ni)	USPAT	2000/09/21 14:39
-	102	((("438/149") or ("438/479") or ("438/517") or ("438/151") or ("438/473") or ("438/476") or ("438/486") or ("438/487") or ("438/491"))).CCLS.) and (nickle or Ni)) and (irradiat\$)	USPAT	2000/09/21 14:39
-	12	((("438/149") or ("438/479") or ("438/517") or ("438/151") or ("438/473") or ("438/476") or ("438/486") or ("438/487") or ("438/491"))).CCLS.) and (nickle or Ni)) and (irradiat\$) and (phosph\$)	USPAT	2000/09/22 08:55
-	4	((("5594569") or ("5643826") or ("5923962") or ("5854096"))).PN.	USPAT	2000/09/22 09:56
-	170	((yamazaki adj shunpei).in.) and nickel	USPAT	2000/09/22 09:57
-	29	((yamazaki adj shunpei).in.) and nickel) and getter\$	USPAT	2000/09/22 09:57
-	26	((yamazaki adj shunpei).in.) and nickel) and phosphor\$	USPAT	2000/09/22 09:58
-	78	((yamazaki adj shunpei).in.) and nickel) and (TFT or (thin adj flim adj transistor))	USPAT	2000/09/22 09:59
-	78	((yamazaki adj shunpei).in.) and nickel) and (TFT or (thin adj flim adj transistor))) and method	USPAT	2000/09/22 10:00
-	17	((yamazaki adj shunpei).in.) and nickel) and (TFT or (thin adj flim adj transistor))) and method) and phosphor\$	USPAT	2000/09/22 10:00
-	3088	(yamazaki adj shunpei).in.	USPAT; JPO; IBM TDB	2000/09/22 11:05
-	280	((yamazaki adj shunpei).in.) and nickel	USPAT; JPO; IBM TDB	2000/09/22 11:05

-	47	((yamazaki adj shunpei).in.) and nickel) and getter\$	USPAT; JPO; IBM TDB	2000/09/22 11:06
-	11	((yamazaki adj shunpei).in.) and nickel) and getter\$) and phosphor\$	USPAT; JPO; IBM TDB	2000/09/22 11:08
-	172	((438/482) or (438/150)).CCLS.	USPAT	2000/09/22 12:38
-	37	((438/482) or (438/150)).CCLS.) and TFT	USPAT	2000/09/22 12:38
-	9	((5854096) or (5712191) or (5696386) or (5960323) or (5643826) or (6093937) or (6121076) or (5616506) or (5888857)).PN.	USPAT	2000/09/25 13:31
-	2	((5594569) or (5923962)).PN.	USPAT	2001/04/16 08:42
-	0	(Ni or nickel or metal) with (UV or ultraviolet or IR or infrared) with (amorphous adj silicon) with TFT	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 08:43
-	41	(Ni or nickel or metal) with (UV or ultraviolet or IR or infrared) with (amorphous adj silicon)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 08:43
-	13	(Ni or nickel or metal) with (UV or ultraviolet or IR or infrared) with (amorphous adj silicon) and TFT	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 08:50
-	81	TFT and (Si adj Ge)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 08:50
-	37	(TFT and (Si adj Ge)) and Ni	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 08:59
-	27	((TFT and (Si adj Ge)) and Ni) and (UV or IR or ultraviolet or infrared)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 09:03
-	114	TFT and SiGe	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 09:03
-	20	(TFT and SiGe) and Ni	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 09:04
-	40	(TFT and SiGe) and (UV or IR or ultraviolet or infrared)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 09:04
-	15	((TFT and SiGe) and Ni) and (UV or IR or ultraviolet or infrared)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 09:07
-	11	TFT with SiGe	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/04/16 09:07

-	1	("6093937").PN.	USPAT	2001/04/16 12:57
-	4	("5569610").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2001/10/10 16:17
-	0	(peabody).at.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/10/10 16:17
-	893	(peabody).att.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/10/10 16:17
-	796	(yamazaki adj shunpei).in.	USPAT	2001/10/10 16:19
-	23	Freidman.att.	USPAT	2001/10/10 16:19
-	9412	(fish with richardson).att.	USPAT	2001/10/10 16:19
-	0	((fish with richardson).att.) and ((semiconductor adj energy adj lab).as.)	USPAT	2001/10/10 16:21
-	217	((fish with richardson).att.) and ((semiconductor adj energy adj laboratory).as.)	USPAT	2001/10/10 16:22
-	29	((fish with richardson).att.) and ((semiconductor adj energy adj laboratory).as.)) and (catalytic and laser)	USPAT	2001/10/11 08:59
-	1	Freidman.att. and (catalytic and laser)	USPAT	2001/10/10 16:22
-	36	((peabody).att.) and (catalytic and laser)	USPAT	2001/10/11 08:48